



IFW
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

5 In re application of:

Gotkis et al.

10 Application No: 10/674,373

Filed: September 29, 2003

15 For: APPARATUS AND METHOD FOR
CONTROLLING FILM THICKNESS IN A
CHEMICAL MECHANICAL PLANARIZATION
SYSTEM

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) Docket No: LAM2P445

) Group Art Unit: 3723

) Examiner: Rachuba, Maurina T.

) Date: Aug. 31, 2007

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being
) deposited with the United States Postal Service as
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) P.O. Box 1450, Alexandria, VA 22313-1450 on
) Aug. 31, 2007.

Signed: *Kay Harlow*
Kay Harlow

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AMENDMENT

Mail Stop: *Amendment*
Commissioner for Patents
P.O. Box 1450
30 Alexandria, VA 22313-1450

Dear Sir:

35 This Amendment is submitted in response to the Office Action dated May 7,
2007, with a one month extension. Please enter the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims which begins on
page 2 of this Amendment.

Remarks/Arguments begin on page 7 of this Amendment.

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